

<b>Notice of References Cited</b>	Application/Control No. 10/601,253		Applicant(s)/Patent Under Reexamination JEDDELOH ET AL.	
	Examiner Hong C. Kim		Art Unit 2185	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,820,181	11-2004	Jeddeloh et al.	711/169
*	B	US-6,980,042	12-2005	LaBerge, Paul A.	327/291
*	C	US-2003/0229770	12-2003	Jeddeloh, Joseph M.	711/213
*	D	US-2004/0024978	02-2004	Jeddeloh, Joseph M.	711/154
*	E	US-2004/0034753	02-2004	Jeddeloh, Joseph M.	711/163
*	F	US-2004/0034825	02-2004	Jeddeloh, Joseph M.	714/733
*	G	US-2004/0044857	03-2004	Jeddeloh et al.	711/154
*	H	US-2004/0260864	12-2004	Lee et al.	711/101
*	I	US-2004/0260909	12-2004	Lee et al.	711/213
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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